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FIRST NAMED INVENTOR APPLICATION NO. FILING DATE Herbert Huttlin 03928- P0005A 6984 10/788,428 02/27/2004 EXAMINER 24126 11/18/2005 LU, JIPING ST. ONGE STEWARD JOHNSTON & REENS, LLC 986 BEDFORD STREET ART UNIT PAPER NUMBER STAMFORD, CT 06905-5619 3749

DATE MAILED: 11/18/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)	
	10/788,428	HUTTLIN, HERBERT	
Office Action Summary	Examiner	Art Unit	
	Jiping Lu	3749	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply			
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).			
Status			
1) Responsive to communication(s) filed on			
2a) This action is <b>FINAL</b> . 2b) This action is non-final.			
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is			
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.			
Disposition of Claims			
<ul> <li>4)  Claim(s) 1-14 is/are pending in the application.</li> <li>4a) Of the above claim(s) is/are withdray</li> <li>5)  Claim(s) is/are allowed.</li> <li>6)  Claim(s) 1,2,7 and 11-14 is/are rejected.</li> <li>7)  Claim(s) 3-6 and 8-10 is/are objected to.</li> <li>8)  Claim(s) are subject to restriction and/or</li> </ul>	vn from consideration.		
Application Papers			
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) access Applicant may not request that any objection to the Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Examine 11.	epted or b) objected to by the Edrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
<ul> <li>12) Acknowledgment is made of a claim for foreign</li> <li>a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents</li> <li>2. Certified copies of the priority documents</li> <li>3. Copies of the certified copies of the prior application from the International Bureau</li> <li>* See the attached detailed Office action for a list of</li> </ul>	s have been received. s have been received in Application ity documents have been received (PCT Rule 17.2(a)).	on No ed in this National Stage	
Attachment(s)			
<ol> <li>Notice of References Cited (PTO-892)</li> <li>Notice of Draftsperson's Patent Drawing Review (PTO-948)</li> <li>Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date <u>2/27/04</u>.</li> </ol>	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal Pa		

## **DETAILED ACTION**

## Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1-2, 7, 11, 13-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Huttlin (U. S. Pat. 5,145,650) in view of Huttlin (U. S. Pat. 6,367,165) and Gribanov et al. (RU 2151988 C1).

Huttlin ('650) shows an apparatus for treating a particulate material, comprising an elongated, tunnel-like process chamber 12 (see Fig. 1) having an inlet (adjacent 32) and an outlet (adjacent 34), a material to be treated in said process chamber can be moved from said inlet to said outlet (by conveyor belt 30), a bottom of said process chamber has overlapping guide vanes 42 forming slots there between extending in a longitudinal direction of said process chamber, air feed box 20 with chambers (at 16) and blowers (see claim 1). However, Huttlin ('650) does not show guide plates and air guide elements with adjustment device. Huttlin ('165) teaches an apparatus for treating a particulate material with overlapping guide plates 16-18, 20-22 superimposed in the bottom of the process chamber and a process air 54 is introduced via the slots formed by the guide plates 16-18, 20-22 into the process chamber as two flows oriented oppositely toward each other, said two oppositely oriented flows impinge one another along a breaking-up zone 58. Gribanov et al. teach an apparatus for treating a particulate

Art Unit: 3749

material with adjustable air guide elements 2,3,8 for adjusting the air flow same as claimed. Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the particulate material treating apparatus of Huttlin ('650) to include oppositely oriented guide plates as taught by Huttlin ('165) and to further include adjustable air guide elements as taught by Gribanov et al. in order to control air flow and therefore improve the particulate material treating efficiency.

3. Claim 12 is rejected under 35 U.S.C. 103(a) as being unpatentable over Huttlin (U. S. Pat. 5,145,650) in view of Huttlin (U. S. Pat. 6,367,165) and Gribanov et al. (RU 2151988 C1) as applied to claim 11 above, and further in view of Engstrom et al. (U. S. Pat. 5,093,085).

The particulate material treating apparatus of Huttlin ('650) as modified by Huttlin ('165) and Gribanov et al. as above includes all that is recited in claim 12 except for air distribution grid arranged in the air chamber. Engstrom et al. teach a particulate material treating apparatus with air distribution grid 1 arranged in the air chamber 4 for distributing air same as claimed. Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to further modify the particulate material treating apparatus of Huttlin ('650) to include air distribution grid in the air chamber as taught by Engstrom et al. in order to uniformly distribute the air.

## Allowable Subject Matter

4. Claims 3-6, 8-10 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Application/Control Number: 10/788,428

Art Unit: 3749

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jiping Lu whose telephone number is 571 272 4878. The

examiner can normally be reached on Monday-Friday, 9:00 AM - 5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, EHUD GARTENBERG can be reached on 571 272-4828. The fax phone number for

the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Primary Examiner
Art Unit 3749

Page 4

J. L.